

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Ye et al.

Serial No. 10/078,720

Filed: February 19, 2002

For: **METHOD AND APPARATUS FOR  
CUTTING A SUBSTRATE USING  
LASER IRRADIATION**

Attorney's Docket No.: 4795-004



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**Information Disclosure Statement**

Sir:

Attached hereto is an information disclosure statement (PTO-1449). This IDS is being submitted before any action on the merits. As such, no fee is required. However, if fees are required, please deduct from our Deposit Account No. 18-1167.

Respectfully submitted,

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